



December 16, 2003

## MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

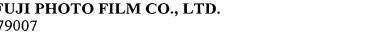
Application of Koichi KAWAMURA and Takeyoshi KANO

PATTERN FORMING METHOD AND SUBSTANCE ADHERENCE

PATTERN MATERIAL

Assignee: FUJI PHOTO FILM CO., LTD.

Our Ref. Q79007





## Dear Sir:

Attached hereto is the application identified above comprising seventy-five (75) sheets of the specification, including the claims and abstract, one (1) sheet of drawings, a copy of an executed Assignment and PTO 1595 form, and a copy of an executed Declaration and Power of Attorney.

The Government filing fee is calculated as follows:

Total claims	23 - 20 2 - 3	=	3 x x	\$18.00 = \$86.00 =	\$54.00 \$.00 \$770.00
TOTAL FILING FEE Recordation of Assignment					<b>\$824.00</b> \$40.00
TOTAL FEE					\$864.00

Checks for the statutory filing fee of \$824.00 and Assignment recordation fee of \$40.00 are attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.



Q79007

Priority is claimed from:

Country	Application No	Filing Date
Japan	2002-364984	December 17, 2002
Japan	2003-53366	February 28, 2003
Japan	2003-55919	March 3, 2003
Japan	2003-412953	December 11, 2003

The priority documents will be filed at a later date.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

SUGHRUE MION, PLLC Telephone: (202) 293-7060 Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373
CUSTOMER NUMBER

Registration No. 23,063